



Handwritten notes: 2815, 1-24-01, #4, and a signature.

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
Makoto INAI, et al.
Serial No.: 09/658,732
Filed: September 11, 2000

New York, New York
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Examiner: ----

For: **FIELD-EFFECT SEMICONDUCTOR DEVICE**

Assistant Commissioner for Patents
Washington, D.C. 20231

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Signature

Date of Signature

Respectfully submitted,

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